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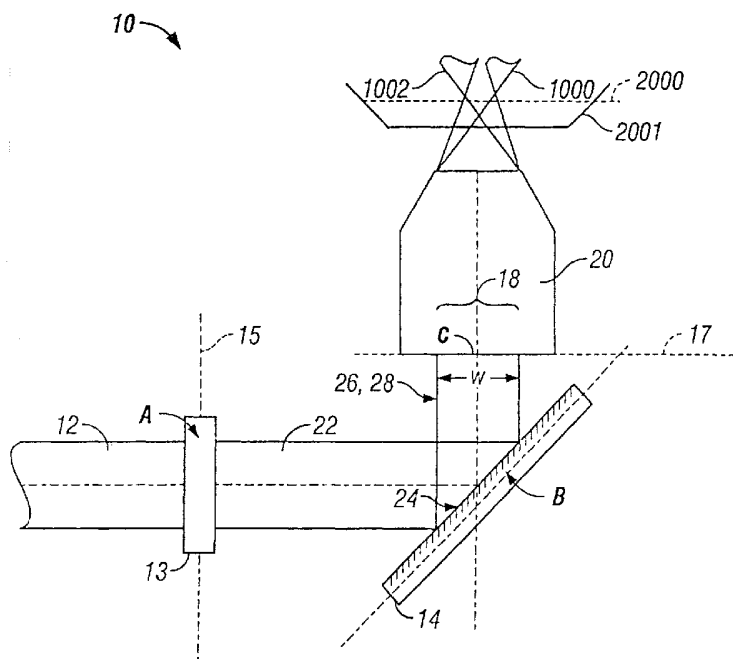
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- (71) Applicant (for all designated States except US): **ARRYX, INC.** [US/US]; 316 North Michigan Avenue, Chicago, IL 60601 (US).
- (72) Inventors; and
- (75) Inventors/Applicants (for US only): **GRIER, David** [US/US]; 1960 N. Lincoln Park West, Chicago, IL 60614 (US). **LOPES, Ward** [US/US]; 1519 E. 54th Street, Apt. 4, Chicago, IL 60615 (US).
- (74) Agents: **EDWARDS, Jean, C.** et al.; Sonnenschein Nath & Rosenthal, P.O. Box 061080, Wacker Drive Station, Chicago, IL 60606-1080 (US).
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[Continued on next page]

(54) Title: APPARATUS AND METHOD TO GENERATE AND CONTROL OPTICAL TRAPS TO MANIPULATE SMALL PARTICLES



(57) Abstract: The present invention relates generally to an apparatus and method to generate and control optical traps (1000, 1002) for manipulation of small particles. An upstream modification of an input laser beam (12, 22) provides a beam with a square or other preselected, cross section of intensity which can be used to form optical traps (1000, 1002) with a corresponding cross section of intensity.

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**APPARATUS AND METHOD TO GENERATE
AND CONTROL OPTICAL TRAPS TO MANIPULATE SMALL PARTICLES.**

BACKGROUND OF THE INVENTION

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Throughout this application various publications are referenced. The disclosures of these publications in their entireties are hereby incorporated by reference in this application in order to more fully describe the state of the art to which this invention pertains.

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1. Field of the Invention

The present invention relates generally to optical traps. In particular, the invention relates to an apparatus, system and method for applying optical gradient forces to form a plurality of optical traps to manipulate small particles.

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2. Discussion of the Related Arts

An optical tweezer is an optical tool which utilizes the gradient forces of a focused beam of light to manipulate particles with dielectric constants higher than the surrounding media. To minimize its energy such particles will move to the area where the electric field is the highest. Stated in terms of momentum, the focused beam of light produces radiation pressure, creating small forces by absorption, reflection, diffraction or refraction of the light by a particle. The forces generated by radiation pressure are almost negligible--a light source, such as a diode-pumped Nd:YAG laser operating at 10mW, will only produce a few picoNewtons. However, a few picoNewtons of force is sufficient to manipulate small particles.

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Other optical tools which can be used to manipulate small particles include, but are not limited to, optical vortices, optical bottles, optical rotators and light cages. An optical vortex, although similar in use to an optical tweezer, operates on an different principle.

An optical vortex produces a gradient surrounding an area of zero electric field which is useful to manipulate particles with dielectric constants lower than the surrounding media or which are reflective, or other types of particles which are repelled by an optical tweezer. To minimize its energy such a particle will move to the area where the electric field is the lowest, namely the zero electric field area at the focal point of an appropriately shaped laser beam.

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The optical vortex provides an area of zero electric field much like the hole in a doughnut (toroid). The optical gradient is radial with the highest electric field at the circumference of the doughnut. The optical vortex detains a small particle within the hole of the doughnut. The detention is accomplished by slipping the vortex over the small particle
5 along the line of zero electric field.

The optical bottle differs from an optical vortex in that it has a zero electric field only at the focus and a non-zero electric field at an end of the vortex. An optical bottle may be useful in trapping atoms and nanoclusters which may be too small or too absorptive to trap with an optical vortex or optical tweezers. *J. Arlt and M.J. Padgett*. "Generation of a beam
10 with a dark focus surrounded by areas of higher intensity: The optical bottle beam," *Opt. Lett.* 25, 191-193, 2000.

The optical rotator provides a pattern of spiral arms which trap objects. Changing the pattern causes the trapped objects to rotate. *L. Paterson, M.P. MacDonald, J. Arlt, W. Sibbett, P.E. Bryant, and K. Dholakia*, "Controlled rotation of optically trapped microscopic
15 particles," *Science* 292, 912-914, 2001. This class of tool may be useful for manipulating non-spherical particles and driving MEMs devices or nano-machinery.

The light cage, (*Neal* in U.S. Patent No. 5,939,716) is loosely, a macroscopic cousin of the optical vortex. A light cage forms a time-averaged ring of optical tweezers to surround a particle too large or reflective to be trapped with dielectric constants lower than the
20 surrounding medium. If the optical vortex is like a doughnut, the light cage is like a jelly-filled doughnut. While the doughnut hole (for the vortex) is an area of zero electric field, the jelly-fill is an area of lowered electric field. In a gross sense, the gradient forces of the plurality of optical tweezers forming the doughnut "push" a particle, with a dielectric constant lower than the surrounding medium, towards the jelly-fill which may also be thought
25 of as the less bright area which lies between the plurality of optical tweezers. However, unlike a *vortex*, no-zero electric field area is created. An optical vortex, although similar in use to an optical tweezer, operates on an opposite principle.

Using a single beam of laser light with a diffractive optical element to form a plurality of diffracted laser beams focused to form an array of optical traps is known in the art. U.S.
30 Patent No. 6,055,106 issued to *Grier and Dufresne* describes arrays of optical traps. The *Grier and Dufresne* patent teaches the use of a dynamic optical element and a focusing lens to diffract the input light beam and generate an array of movable optical traps. The array of optical traps is formed from a single input beam by having an appropriate shape at the back

aperture beam diameter. Specifically, that a gaussian TEM₀₀ input laser beam should have a beam diameter which substantially coincides with the diameter of the back aperture.

One limitation of having the beam diameter of a gaussian TEM₀₀ input laser beam substantially coincides with the diameter of the back aperture is that as shown from a cross sectional view (FIG. 1) a gaussian TEM₀₀ beam has much less intensity at its periphery. The resulting optical traps will have a similar cross section of intensity.

Accordingly, there has existed a need to have an input beam fill the back aperture and produce optical traps with greater intensity at the periphery. The present invention satisfies these and other needs, and provides further related advantages.

SUMMARY OF THE INVENTION

The present invention provides a novel method and system to use gradient forces to generate and control an array of optical traps.

The present invention provides a novel and improved method, system and apparatus for generating, monitoring and controlling an array of optical traps. The optical traps separately, or in concert, can manipulate small particles.

The present invention employs a first phase patterning optical element, to shape the phase profile of the an input beam of light or energy upstream from a second phase patterning optical element which in turn diffracts the input beam into a plurality of beams.

By patterning the phase of the input beam with the upstream phase patterning optical element the patterned input beam's cross section can be selected to have a substantially even intensity (FIG. 2) even near its periphery. The substantially even intensity of the patterned input beam can be transferred to each beamlet. Accordingly, the plurality of beams produced from the second phase patterning optical element can both have a beam width which coincides with the back aperture of a focusing lens and generate optical traps with greater intensity at the periphery of the optical traps than those optical traps produced from unpatterned input beams which have less intensity at there periphery.

To alter the position of a given optical trap, the beam forming that trap may be steered to a new position with only the second phase patterning optical element, thereby altering the position of the optical trap resulting therefrom.

In other embodiments the first and second phase patterning optical elements may work together to alter the position of a given optical trap, by steering the beam forming that trap and thereby altering the position of that optical trap.

5 The selective generation and control of the array of optical may be useful in a variety of commercial applications, such as, optical circuit design and manufacturing, nanocomposite material construction, fabrication of electronic components, opto-electronics, chemical and biological sensor arrays, assembly of holographic data storage matrices, rotational motor, mesoscale or nanoscale pumping, energy source or optical motor to drive MEMS, facilitation of combinatorial chemistry, promotion of colloidal self-assembly, manipulation of biological 10 materials, interrogating biological material, concentrating selected biological material, investigating the nature of biological material, and examining biological material.

The activity of the optical trap array, may be observed via an optical data stream (FIG. 5) by placing a beam splitter in the optical pathway. Viewing can be enhanced by introducing a filter to limit the passage of un-diffracted, scattered or reflected light along the 15 pathway of the optical data stream thus reducing this noise which can disrupt video or other monitoring of the optical data stream.

Other features and advantages of the present invention will be set forth, in part, in the descriptions which follow and the accompanying drawings, wherein the preferred 20 embodiments of the present invention are described and shown, and in part will become apparent to those skilled in the art upon examination of the following detailed description taken in conjunction with the accompanying drawings, or may be learned by practice of the present invention. The advantages of the present invention may be realized and attained by means of the instrumentalities and combinations particularly pointed out in the appendent 25 claims.

DESCRIPTION OF THE DRAWINGS

FIG. 1 is a chart of the intensity of an unmodified gaussian beam's cross section.

30 FIG. 2 is a chart of the intensity of a modified gaussian beam with a square cross section

FIG. 3 illustrates a preferred embodiment of a system for generating optical traps to manipulate small particles.

FIG. 4 illustrates a dual transmissive embodiment of a system for generating optical traps to manipulate small particles.

FIG. 5 illustrates an embodiment of a system for generating optical traps to manipulate small particles with transfer lenses.

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DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

Certain terminology will be used in the following specification, for convenience and reference and not as a limitation, brief definitions are provided below:

10 A. "*Beamlet*" refers to a sub-beam of focused light or other source of energy that is generated by directing a focused beam of light or other source of energy, such as that produced by a laser or collimated output from a light emitting diode, through a media which diffracts it into two or more sub-beams. An example of a beamlet would be a higher order laser beam diffracted off of a grating.

15 B. "*Phase profile*" refers to the phase of light or other source of energy in a cross-section of a beam.

C. "*Phase patterning*" refers to imparting a patterned phase shift to a focused beam of light, other source of energy or beamlet which alters its phase profile, including, but not limited to, phase modulation, mode forming, splitting, converging, diverging, shaping and otherwise steering a focused beam of light, other source of energy or a beamlet.

20 A preferred embodiment of the inventive apparatus for forming a plurality of movable optical traps, generally designated as 10, is shown in FIG. 1. A movable array of optical traps is formed by generating a focused beam of energy, such as electromagnetic wave energy. In the preferred embodiments, the electromagnetic waves are light waves, preferably having a wavelength of from about 400 nm to about 1060 nm, and more preferably having a wavelength in the green spectrum. The beam is formed of a collimated light, such as the collimated gaussian beam output from a laser beam 12, as shown in FIG. 1.

25 The laser beam 12 is directed through area "A" of a first phase patterning optical element 13, situated upstream from the second phase patterning optical element 14, in a plane conjugate 15 to the planar surface 17 at the back aperture 18 of a focusing lens 20. The preferred embodiment of the focusing lens 20 is an objective lens. The phase profile of the laser beam 12 is patterned by the first phase patterning optical element 14 to form a modified laser beam 22 which is directed at the second phase patterning optical element 14. The

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second phase patterning optical element 14 has a reflective variable surface medium 24 which the modified laser beam 22 passes through at area "B" which is disposed substantially opposite the planar surface 17 at the back aperture 18.

5 Beamlets 26 and 28 are formed as the modified laser beam 22 passes through the second phase patterning optical element 14. Each beamlet's 26 and 28 phase profile is selected as the beamlets 26 & 28 are formed. The beamlets then pass through area "C" at the back aperture 18 and are then converged by the focusing lens 20 to form the optical traps 1000 and 1002 in working focal area 2000 of a vessel 2001. The vessel 2001 constructed of a substantially transparent material, which allows the beamlets to pass through and which does
10 not interfere with the formation of the optical traps.

The second phase patterning optical element may also work in cooperation with the focusing lens 20 to converge the beamlets. The beam diameter w of the beamlets is substantially coincide with the diameter of the back aperture 18. Altering the variable surface medium 24 of the second phase patterning optical element selectively patterns the phase
15 profile of each beamlet.

The working focal area 2000 is that area where a media containing particles or other material to be examined, measured or manipulated by the optical traps 1000 and 1002 is located.

For clarity, only two optical traps 1000 and 1002 are shown, but it should be
20 understood that an array of such optical traps can be created by the second phase patterning optical element 14.

Any suitable laser can be used as the source of the laser beam 12. Useful lasers include solid state lasers, diode pumped lasers, gas lasers, dye lasers, alexanderite lasers, free electron lasers, VCSEL lasers, diode lasers, Ti-Sapphire lasers, doped YAG lasers, doped
25 YLF lasers, diode pumped YAG lasers, and flash lamp-pumped YAG lasers. Diode-pumped Nd:YAG lasers operating between 10 mW and 5 W are preferred.

The upstream or first phase patterning optical element is used to at least impart a square cross section (FIG. 2) to the wavefront of the laser beam 12 resulting in a modified laser beam 22 with a square cross section of substantially even intensity. Accordingly, when
30 the beam diameter w of the modified laser beam substantially coincides with the diameter of the back aperture 18 the periphery of the modified laser beam 22 has greater intensity than the periphery of the input beam 12 and the corresponding optical traps 1000 and 1002 will have a corresponding intensity at their periphery. The first phase patterning optical element

may also impart different selected wavefronts depending on the parameter of the system, which may include a wavefront which is most intense at the periphery.

In the embodiments shown in FIGS. 3-6 the type, number orientation and position of each optical trap 1000 & 1002 can be selectively controlled by the hologram encoded on the variable surface medium 24 of the second phase patterning optical element 14 which is used to pattern the phase profile of each beamlet. It is a significant feature of the invention that movement of each trap, be it rotation in a fixed position, rotation in a non-fixed position, two-dimensional and three dimensional, continuous and stepped is selectively controllable. The control in this embodiment is achieved by at least varying the hologram formed in the surface medium 24 of the second phase patterning optical element 14.

Moreover, depending on the type of optical trap desired, the phase patterned by the second phase patterning optical element 16 may include wavefront shaping, phase shifting, steering, diverging and converging to form different classes of optical traps including optical tweezers, optical vortices, optical bottles, optical rotators, light cages, and combinations of the different classes

Suitable phase patterning optical elements are characterized as transmissive or reflective depending on how they direct the focused beam of light. Transmissive phase patterning optical elements, as shown in FIGS. 3, 4 and 5, allow the laser beam 12, or in the case of FIG. 4 the laser beam 12 and modified laser beam 22, to pass through. Reflective phase patterning optical elements, as shown in FIGS. 3 and 5, reflect the modified laser beam 22. The upstream, first, phase patterning optical element although shown as a transmissive element in the figures may instead be reflective without departing from the scope of the invention.

Within the two general groups, a phase patterning optical element can be formed from either static or dynamic media. Examples of suitable static phase patterning optical elements include diffractive optical elements with a fixed surface, such as gratings, including diffraction gratings, reflective gratings, transmissive gratings, holograms, stencils, light shaping holographic filters, polychromatic holograms, lenses, mirrors, prisms, waveplates and the like.

The static phase patterning optical element may have different areas, each area configured to impart a different phase profile to the beamlets. In such embodiments, the surface of the static phase patterning optical element can be varied by moving the surface relative to the laser beam to select the appropriate area to change the desired characteristics

imparted to the beamlets, i.e., to change the desired phase profile of at least one of the resulting beamlets.

Examples of suitable dynamic phase patterning optical elements having a time dependent aspect to their function include variable computer generated diffractive patterns, variable phase shifting materials, variable liquid crystal phase shifting arrays, micro-mirror arrays, piston mode micro-mirror arrays, spatial light modulators, electro-optic deflectors, accousto-optic modulators, deformable mirrors, reflective MEMS arrays and the like. With a dynamic phase patterning optical element, the features of the surface can be encoded, as previously noted to form a hologram and altered, for example, by a computer, to effect a change in the hologram which can affect the number of beamlets, the phase profile of at least one of the beamlets, and the location of at least one of the beamlets.

Preferred dynamic phase patterning optical elements include phase-only spatial light modulators such as the "PAL-SLM series X7665, manufactured by Hamamatsu of Japan, or "SLM 512SA7" and "SLM 512SA15" both manufactured by Boulder Nonlinear Systems of Lafayette Colorado. These encodeable phase pattern optical elements are computer controllable and multifunctional, so that they can generate the beamlets 26 and 28 by diffracting the modified laser beam 15 and selectively impart desired phase profile (characteristic) to the resulting beamlets.

Turning to the embodiment shown in FIG. 4, the controllable optical traps 42 and 44 are formed by passing the laser beam 12 through area "A" of the first phase patterning optical element 13 which is disposed substantially in a plane 46 opposite the planar surface 17 at the back aperture 18 through which the phase profile of the laser beam 12 is patterned to form a modified laser beam 22 which is directed at a second phase patterning optical element 48.

The second phase patterning optical element 48 has a transmissive variable surface medium 50 which the modified laser beam 22 passes through at area "B" which is disposed substantially opposite the planar surface 17 at the back aperture 18. Beamlets 52 and 54 are formed as the modified laser beam 22 passes through the second phase patterning optical element 48. Each beamlet's 52 and 54 phase profile is selected as the beamlets are formed. The beamlets then pass through area "C" at the back aperture 18 and are then converged by the focusing lens 20 to form the optical traps 42 and 44 in working focal area 2000. The beam diameter "w" of the modified laser beam 22 substantially coincides with the diameter of the back aperture 18. Altering the variable surface medium 50 of the second phase patterning optical element selectively patterns the phase profile of each beamlet.

For clarity, only two optical traps 42 and 44 are shown, but it should be understood that an array of such optical traps can be created by the second phase patterning optical element 48.

5 The embodiment shown in FIG. 5, using additional transfer optics, in some cases can minimize beamlet misalignments. Transfer optics may be particularly useful when the beamlets 62 and 64 are generated off a reflective second phase patterning optical element, or when a data stream to allow behind the focusing lens observation of the activity of the optical traps 66 and 68 is desirable.

10 A conventional telescope system 70 is disposed between the second phase patterning optical element 14 and a beam splitter 72. The beam splitter 72 is constructed of a dichroic mirror, photonic band gap mirror, omnidirectional mirror, or other similar device. The beam splitter 72 selectively reflects the wavelength of light used to form the optical traps (beamlets 62 and 64) and transmits other wavelengths such as the imaging illumination 74 provided by an illumination source 76 above the focusing lens 20. The portion of light reflected from the
15 beam splitter 72, which is used to form the optical traps, is then passed through an area "C" of the back aperture 18 of the focusing lens 20.

The imaging illumination 74 passes through the working area 200, along the optical axis of the focusing lens, forming an optical data stream 78 corresponding to the phase profile and location of one or more of the beamlets, derived from the location and position of a small
20 particle contained by an optical trap.

An optical filter element 80, such as a polarizing element or band pass element, is placed within the pathway of the optical data stream 78 to reduce the amount of reflected, scattered or undiffracted laser light passing along the axis of the optical data stream. The filter element 80 filters out one or more preselected wavelengths and, in some embodiments,
25 all but a preselected wavelength of the optical data stream 78.

The optical data stream 78 can then be viewed, converted to a video signal, monitored, or analyzed by visual inspection of an operator, spectroscopically, and/or video monitoring. The optical data stream 78 may also be processed by a photodetector to monitor intensity, or any suitable device to convert the optical data stream to a digital data stream
30 adapted for use by a computer.

To trap small particles an operator and/or the computer will adjust the second phase patterning optical element 14 to direct the movement of each optical trap to acquire a selected small particle and trap it. The plurality of optical traps with contained small particles can

then be configured and reconfigured. Using the optical data stream, the position and identity of one or more of the trapped small particles can be monitored, via video camera, spectrum, or an optical data stream which provides a computer controlling the selection of probes and generation of optical traps information useful to adjusting the type of small particles
5 contained by the optical traps. The movement can be tracked based on predetermined movement of each optical trap caused by encoding the phase patterning optical element. Additionally a computer may be used to maintain a record of each probe contained in each optical trap.

Other features and advantages of the present invention will be set forth, in part, in the
10 descriptions which follow and the accompanying drawings, wherein the preferred embodiments of the present invention are described and shown, and, in part, will become apparent to those skilled in the art upon examination of the following detailed description taken in conjunction with the accompanying drawings, or may be learned by practice of the present invention. The advantages of the present invention may be realized and attained by
15 means of the instrumentalities and combinations particularly pointed out in the appendant claims.

We claim:

1. An apparatus for trapping small particles by forming optical traps, comprising:
a first phase patterning optical element for receiving a laser beam and to impart a
5 selected cross section to the wavefront of the laser beam;
a second phase patterning optical element downstream from the first phase patterning
optical element for receiving a laser beam and forming at least two beamlets; and,
a focusing lens with a front and a back aperture disposed downstream from the second
phase patterning optical element; whereby the second phase patterning optical element in
10 cooperation with the focusing lens can separately converge beamlets and establish the
gradient conditions to form optical traps capable of manipulating small particles.
2. The apparatus of claim 1 wherein the first phase patterning optical element, is selected
15 from the group consisting of transmissive and reflective.
3. The apparatus of claim 2 wherein the first phase patterning optical element, is selected
from the group consisting of static and dynamic.
4. The apparatus of claim 3 wherein the first phase patterning optical element is selected
20 from the group consisting of gratings, diffraction gratings, reflective gratings, transmissive
gratings, holograms, stencils, light shaping holographic filters, polychromatic holograms,
lenses, mirrors, prisms, and waveplates.
5. The apparatus of claim 3 wherein the first phase patterning optical element is selected
25 from the group consisting of variable computer generated diffractive patterns, variable phase
shifting materials, variable liquid crystal phase shifting arrays, micro-mirror arrays, piston
mode micro-mirror arrays, spatial light modulators, electro-optic deflectors, accousto-optic
modulators, deformable mirrors, and reflective MEMS arrays.
- 30 6. The apparatus of claim 1 wherein the first and second phase patterning optical
elements are selected from the group consisting of transmissive and reflective.

7. The apparatus of claim 1 wherein the first and second phase patterning optical elements are selected from the group consisting of static and dynamic.
8. The apparatus of claim 7 wherein at least one of the first and second phase patterning optical elements is selected from the group consisting of gratings, diffraction gratings, reflective gratings, transmissive gratings, holograms, stencils, light shaping holographic filters, polychromatic holograms, lenses, mirrors, prisms, and waveplates.
9. The apparatus of claim 7 wherein at least one first phase patterning optical element, is dynamic and selected from the group consisting of variable computer generated diffractive patterns, variable phase shifting materials, variable liquid crystal phase shifting arrays, micro-mirror arrays, piston mode micro-mirror arrays, spatial light modulators, electro-optic deflectors, acousto-optic modulators, deformable mirrors, and reflective MEMS arrays.
10. The apparatus of claim 3 wherein the first phase patterning optical element is a phase-only spatial light modulator.
11. The apparatus of claim 7 wherein at least one of the first and second phase patterning optical element is a phase-only spatial light modulator.
12. The apparatus of claim 1 further comprising a means for generating a laser beam.
13. The apparatus of claim 12 wherein the means for generating the laser beam is selected from the group consisting of solid state lasers, diode pumped lasers, gas lasers, dye lasers, alexanderite lasers, free electron lasers, VCSEL lasers, diode lasers, Ti- Sapphire lasers, doped YAG lasers, doped YLF lasers, diode pumped YAG lasers, and flash lamp-pumped YAG lasers.
14. The apparatus of claim 1 wherein said focusing lens is an objective lens.
15. The apparatus of claim 1 further comprising a beam splitter disposed opposite the back aperture of the focusing lens, whereby beamlets can be directed at the back aperture and

an optical data stream can pass along the optical axis of the focusing lens from front to back aperture.

16. The apparatus of claim 15 further comprising an optical filter selected from the group
5 consisting of polarizing and band pass disposed along the optical axis of the focusing lens and behind the beam splitter.

17. The apparatus of claim 1 further comprising at least one telescope lens system
10 disposed between upstream from the focusing lens and downstream from the second phase patterning optical element

18. The apparatus of claim 15 further comprising at least one telescope lens system disposed upstream from the beam splitter.

15 19. The apparatus of claim 15 further comprising at least one telescope lens system disposed downstream from the beam splitter.

20. The apparatus of claim 15 further comprising at least one telescope lens system disposed upstream and downstream from the beam splitter.

20 21. The apparatus of claim 1 wherein the selected cross section is substantially square.

22. The apparatus of claim 1 wherein the selected cross section is intense at its periphery.

25 23. A system for trapping small particles by forming movable optical traps, comprising:
a phase patterning optical element for receiving a laser beam and to impart a square cross section to the wavefront of the laser beam;

at least one computer;

30 a dynamic phase patterning optical element with a variable surface encoded, by the computer, with a hologram for receiving a laser beam from the phase patterning optical element; whereby movable beamlets can be formed from a received laser beam; and,

an objective lens with a front and a back aperture disposed downstream from the dynamic phase patterning optical element; whereby the dynamic phase patterning optical

element in cooperation with the objective lens can separately converge beamlets and establish the gradient conditions to form optical traps capable of manipulating small particles.

24. The system of claim 23 further comprising a means for generating a laser beam.

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25. The system of claim 23 further comprising a beam splitter disposed opposite the back aperture of the objective lens, whereby beamlets can be directed at the back aperture and an optical data stream can pass along the optical axis of the focusing lens from front to back aperture.

10

26. The system of claim 23 further comprising a means for converting the optical data stream to a digital data stream adapted for use by a computer.

15

27. The system of claim 23 further comprising at least one telescope lens system disposed upstream from the objective lens.

28. The system of claim 25 further comprising at least one telescope lens system disposed upstream from the beam splitter.

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29. The system of claim 25 further comprising at least one telescope lens system disposed downstream from the beam splitter.

30. The system of claim 25 further comprising at least one telescope lens system disposed upstream and downstream from the beam splitter.

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31. The system of claim 26 further comprising an illumination source.

32. The system of claim 23 wherein the selected cross section is substantially square.

30

33. The system of claim 23 wherein the selected cross section is intense at its periphery.

34. A method for trapping small particles, comprising :

generating a modified laser beam by imparting a square cross section to the wavefront of a laser beam direct at a first phase patterning optical element;

generating at least two beamlets by directing the modified laser beam at a second phase patterning optical element;

5 generating optical traps with a vessel by directing the laser beam through a focusing lens;

providing at least two small particles; and

containing the small particles in the optical traps.

10 35. The method of claim 34 wherein the selected cross section is square.

36. The method of claim 35 wherein the selected cross section has the most intensity at its periphery.

15 37. A method for manipulating small particles with optical traps, comprising:

generating a modified laser beam by imparting a selected cross section to the wavefront of a laser beam direct at a first phase patterning optical element;

generating at least two beamlets by directing the modified laser beam at a second phase patterning optical element;

20 generating optical traps within a vessel by directing the beamlets through a focusing lens;

providing at least two small particles within the vessel; and

containing at least one small particle within an optical trap.

25 38. The method of claim 37, further comprising altering the position of at least one optical trap.

39. The method of claim 37, wherein the optical traps are formed of two or more of optical tweezers, optical vortices, optical bottles, optical rotators, or light cages.

30 40. The method of claim 37 wherein the selected cross section is square.

41. The method of claim 37 wherein the selected cross section has the most intensity at its periphery.

42. The method of claim 37, wherein each optical trap is independently movable.
43. The method of claim 37, wherein the movement of each optical trap is controlled by a
5 computer.
44. The method of claim 37, wherein the movement of each optical trap is controlled by a computer.
- 10 45. A method for manipulating small particles with optical traps, comprising:
generating a modified laser beam by imparting a selected cross section to the
wavefront of a laser beam directed at a first phase patterning optical element;
generating at least two beamlets by directing the modified laser beam at a second
phase patterning optical element;
15 providing an optical data stream;
generating optical traps within a vessel by directing the beamlets through a focusing
lens;
providing at least two small particles within the vessel; and
containing at least one small particle within an optical trap.
- 20 46. The method of claim 45 wherein the movement of each optical trap is controlled by a computer.
47. The method of claim 45, further comprising receiving the optical data-stream with a
25 computer.
48. The method of claim 45, further comprising analyzing the optical data stream with the computer.
- 30 49. The method of claim 46, wherein the computer directs the movement of at least one optical trap based on the analysis of the optical data stream.

50. The method of claim 45, further comprising converting the optical data-stream to a video signal.
51. The method of claim 50, further comprising receiving the video signal with a
5 computer.
52. The method of claim 51, further comprising analyzing the video signal with the computer.
- 10 53. The method of claim 51, further comprising using the computer to direct the movement of one or more optical traps based on the analysis of the video signal.
54. The method of claim 50, wherein the video signal is used to produce an image.
- 15 55. The method of claim 54, further comprising an operator viewing the image and directing the movement of one or more optical traps based on the viewing of the image.
56. The method of claim 45, wherein the optical data stream is spectroscopic data.
- 20 57. The method of claim 56, further comprising using a computer to direct the movement of one or more optical traps based on an analysis of the spectroscopic data.
58. The method of claim 45, wherein the optical traps are formed of two or more of optical tweezers, optical vortices, optical bottles, optical rotators, or light cages.
- 25 59. The system of claim 45 wherein the selected cross section is intense at its periphery.
60. The method of claim 36 wherein the selected cross section has the most intensity at its periphery.

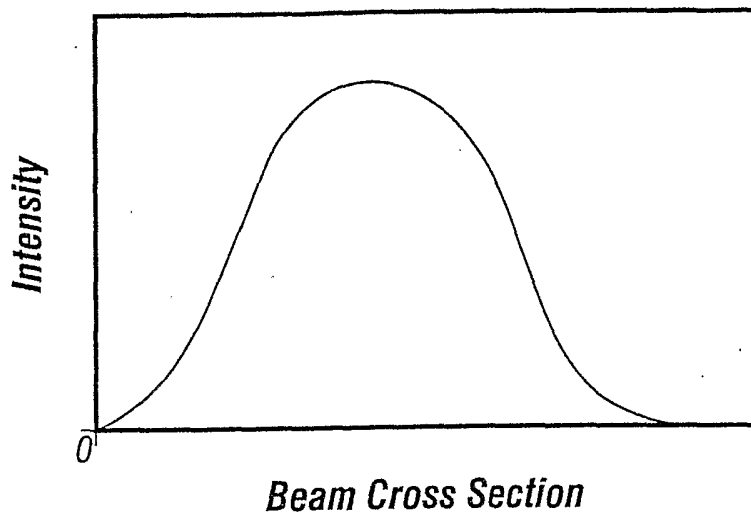


FIG. 1

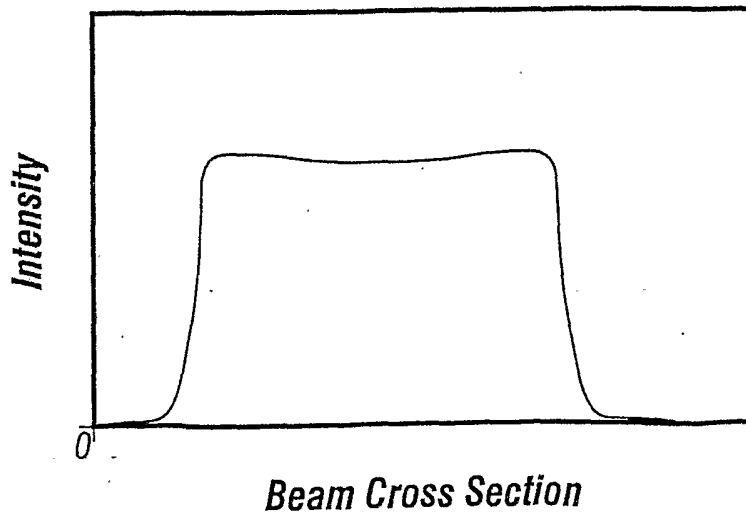


FIG. 2

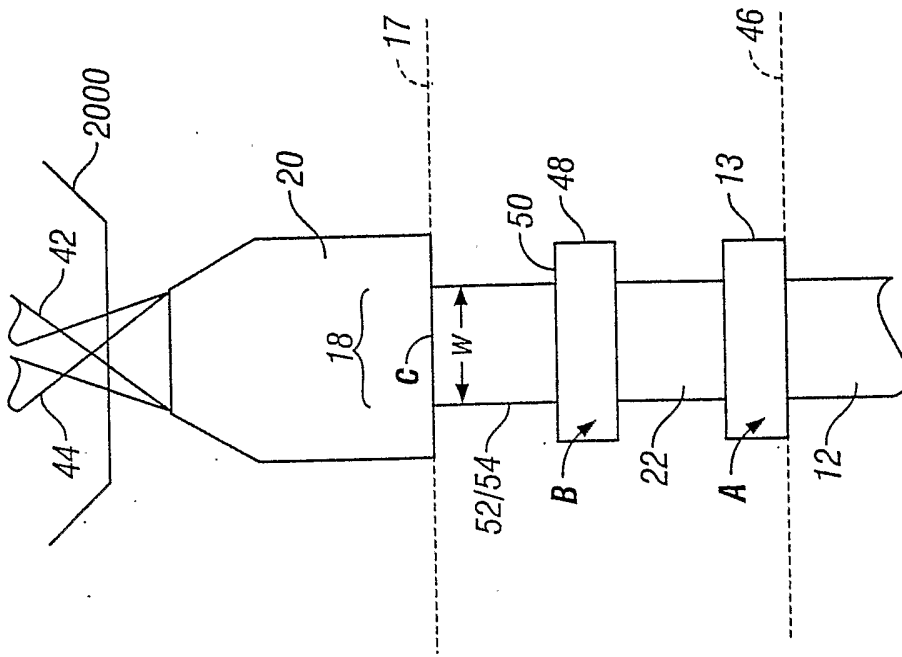


FIG. 4

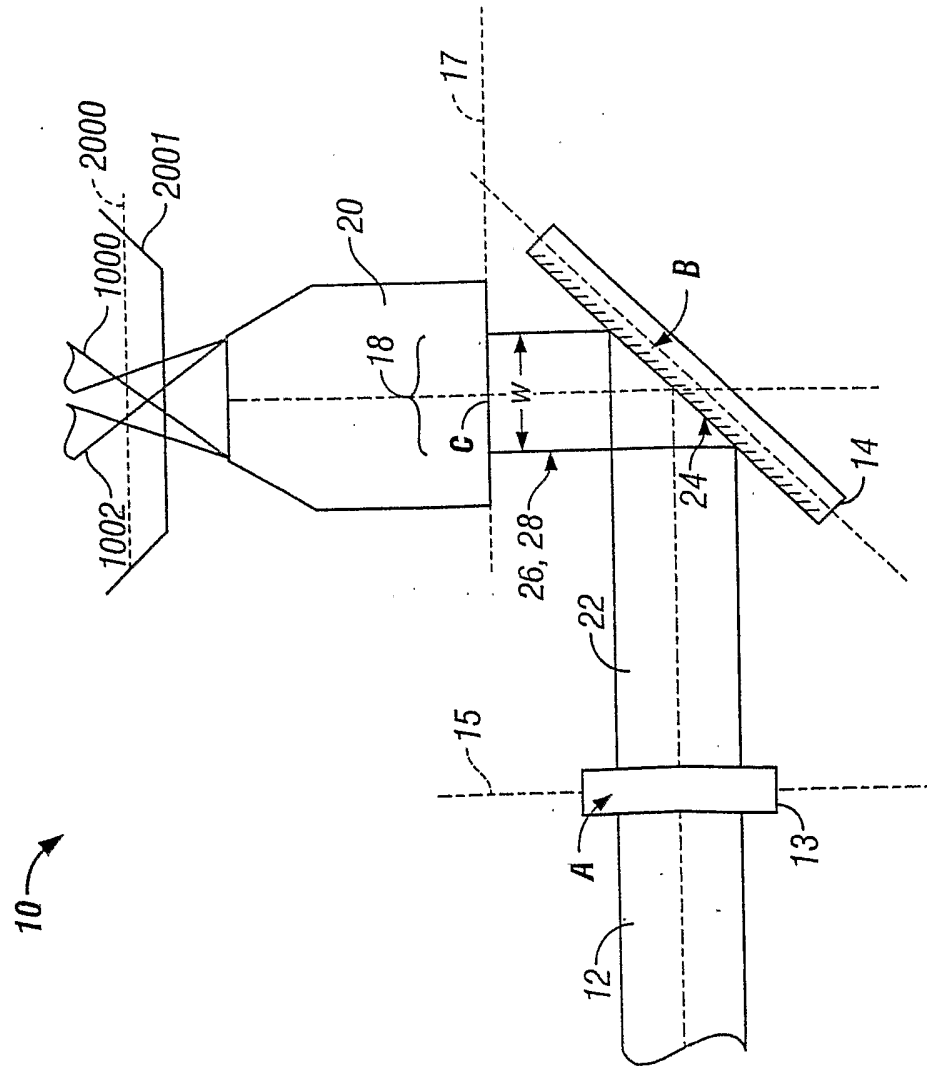


FIG. 3

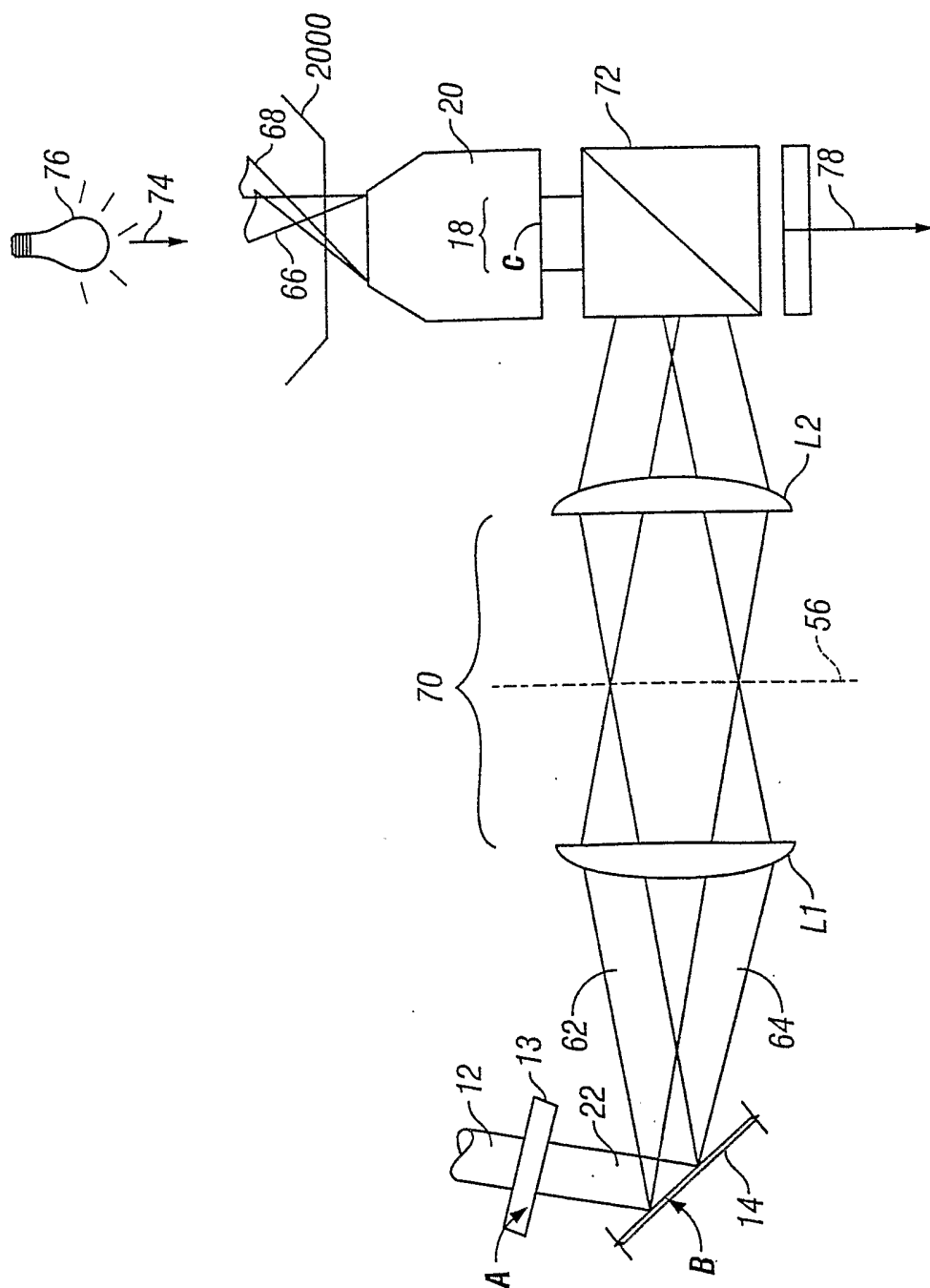


FIG. 5

INTERNATIONAL SEARCH REPORT

International application No.
PCT/US03/10936

A. CLASSIFICATION OF SUBJECT MATTER
IPC(7) : H05H 3/04
US CL : 250/251, 359/350,264/482,
According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
U.S. : 250/251; 359/350; 264/482.

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched
Mogensen et al. Optics Communications, 175,75-81, 15 February 2000.

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)
EAST

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Y --- A	US 5,939,716 A (Neal) 17 August 1999 (17.08.1999), see entire document.	1-2 ,6,12,14,23- 24,34,37,45. ----- 3-5,7-11,13,15-22,25- 33,35-36,38-44,46-60
Y --- A	Mogensen et al., « Dynamic Array Generation and Pattern Formation for Optical Tweezers,Optics Communications», 15 February 2000, Vol. 175, pages 75-81, see entire document.	1-2,6,12,14,23- 24,34,37,45 ----- 3-5,7-11,13,15-22,25- 33,35-36,38-44,46-60

Further documents are listed in the continuation of Box C. See patent family annex.

* Special categories of cited documents:	"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
"A" document defining the general state of the art which is not considered to be of particular relevance	"X" document of particular relevance, the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
"E" earlier application or patent published on or after the international filing date	"Y" document of particular relevance, the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art
"I" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)	"&" document member of the same patent family
"O" document referring to an oral disclosure, use, exhibition or other means	
"P" document published prior to the international filing date but later than the priority date claimed	

Date of the actual completion of the international search
04 June 2003 (04.06.2003)

Date of mailing of the international search report
26 SEP 2003

Name and mailing address of the ISA/US
Mail Stop PCT, Attn: ISA/US
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450
Facsimile No. (703)305-3230

Authorized officer
JOHN R LEE *Diane Smith*
Telephone No. 703-308-0956

INTERNATIONAL SEARCH REPORT

International application No.
PCT/US03/10936

Box I Observations where certain claims were found unsearchable (Continuation of Item 1 of first sheet)

This international report has not been established in respect of certain claims under Article 17(2)(a) for the following reasons:

- 1. Claim Nos.:
because they relate to subject matter not required to be searched by this Authority, namely:

- 2. Claim Nos.:
because they relate to parts of the international application that do not comply with the prescribed requirements to such an extent that no meaningful international search can be carried out, specifically:

- 3. Claim Nos.:
because they are dependent claims and are not drafted in accordance with the second and third sentences of Rule 6.4(a).

Box II Observations where unity of invention is lacking (Continuation of Item 2 of first sheet)

This International Searching Authority found multiple inventions in this international application, as follows:

- 1. As all required additional search fees were timely paid by the applicant, this international search report covers all searchable claims.
- 2. As all searchable claims could be searched without effort justifying an additional fee, this Authority did not invite payment of any additional fee.
- 3. As only some of the required additional search fees were timely paid by the applicant, this international search report covers only those claims for which fees were paid, specifically claims Nos.:

- 4. No required additional search fees were timely paid by the applicant. Consequently, this international search report is restricted to the invention first mentioned in the claims; it is covered by claims Nos.:

Remark on Protest The additional search fees were accompanied by the applicant's protest.
 No protest accompanied the payment of additional search fees.